

<b>FORM 1449*</b> <b>INFORMATION DISCLOSURE STATEMENT</b> <b>IN AN APPLICATION</b> <small>(Use several sheets if necessary)</small>			Docket Number: STFD.039PA	Application Number: 10/663,935
			Applicant: EL GAMAL et al.	
			Filing Date: 09/16/2003	Group Art Unit: 2886

<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,841,348	6/20/1989	Shizukuishi	999	030	
	5,073,029	12/17/1991	Eberly	356	432	
	5,461,425	10/24/1995	Fowler	348	294	
	5,942,775	8/24/1999	Yiannoulos	257	292	
	6,085,576	7/11/2000	Sunshine	073	029.010	
	6,150,189	11/21/2000	Pan	438	059	
	6,150,683	11/21/2000	Merrill	257	292	
	6,518,085	2/11/2003	Wang	438	070	
	6,784,982	8/31/2004	Blumenfeld	356	071	
	7,122,408	10/17/2006	Mouli	438	134	
	7,145,645	12/05/2006	Blumenfeld	356	073	
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Chamberlain, Savvas G., "Photosensitivity and Scanning of Silicon Image Detector Arrays", IEEE Journal of Solid-State Circuits, Vol. SO-4, No. 6, December 1969.				
		Noble, Peter J., "Self-Scanned Silicon Image Detector Arrays", IEEE Transactions on Electron Devices, Vol. Ed. 15, No. 4, April 1968.				

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	